

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Koops et al

Title: Procedure for etching of materials at the surface with focussed electron beam induced chemical reaction at said surface

Filing Date: July 28, 2003

Serial No. : 10/628,174

Examiner: Allan W. Olsen

Group Art Unit: 1792

Attorney Docket No.: 8183

Date: May 28, 2008

Confirmation no. 5591

**NOTICE OF APPEAL FROM THE EXAMINER TO THE  
BOARD OF PATENT APPEALS AND INTERFERENCES**

Now comes the applicant by and through its attorneys and hereby appeals the final rejection of claims 45-68 in the application. Claims 45-68 of the application were finally rejected in a final office action dated January 28, 2008.

The Notice of Appeal fee is being paid electronically. Please charge deposit account 23-3060 for any fee deficiency and please credit any overpayment to said account.

Respectfully submitted,

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/Kenneth L. Mitchell/

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